PATENT
Atty. Dkt. AMAT/8338/DSM/LOW K/JW

No fee

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: §
    Li, et al. §
 §
Serial No.: 10/645,675 §
 §
Confirmation No.: Unknown §
 §
Filed: August 20, 2003 §
 §
For: Methods of Reducing §
    Plasma-Induced Damage §
    for Advanced Plasma CVD §
    Dielectrics §
	Group Art Unit: Unknown
	
	Examiner: Unknown

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

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If the sum of $180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/8338/KMT.

Respectfully submitted,

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U.S. Department of Commerce, Patent and Trademark Office		Docket No.	Serial No.
(PTO Form 1449 modified)		AMAT/8338/DSM/LOWK /JW	10/645,675
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant Li, et al.	Confirmation No. Unknown
(Use several sheets if necessary)		Filing Date August 20, 2003	Group Unknown
	Examiner Unknown		

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
	A1	6,521,302	02/18/2003	Campana-Schmitt, et al.	427	574	09/26/2000
	A2	6,159,871	12/12/2000	Loboda, et al.	438	786	05/29/1998
	A3	5,728,259	03/17/1998	Suzawa, et al.	156	646.1	10/19/1995
	A4	5,540,821	07/30/1996	Tepman	204	192.13	07/16/1993
	A5	5,271,972	12/21/1993	Kwok, et al.	427	579	08/17/1992
	A6	2003/0124874	07/03/2003	Matsuki	438	778	12/20/2002
	A7	2003/0092284	05/15/2003	Huang, et al.	438	763	11/13/2001
	A8	2002/0029853	03/14/2002	Hudson, et al.	156	345	05/30/2001
	A9	2001/0014520	08/16/2001	Usui, et al.	438	586	02/16/2001
	A10						
	A11						
	A12						
	A13						
	A14						
	A15						

Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
	B1	1 191 569	03/27/2002	EP	H01L	37/32	☐	☒
	B2	2002 176047	06/21/2002	JP	H01L	2/31	☒	☐

OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	
	C2	
	C3	

Examiner	Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.